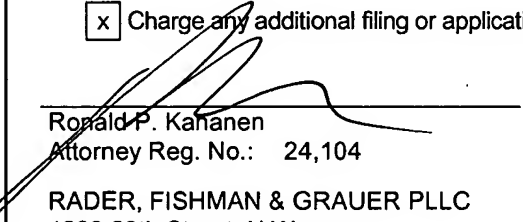


*Handwritten signature/initials*

AMENDMENT TRANSMITTAL LETTER				Docket No. SON-1908/DIV	
Application No. 10/759,194-Conf. #7751		Filing Date January 20, 2004		Examiner F. L. Toledo	
				Art Unit 2823	
Applicant(s): Takeshi Nogami et al.					
Invention: METHOD FOR PRODUCING SEMICONDUCTOR DEVICE, POLISHING APPARATUS, AND POLISHING METHOD					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	33	- 30 =	3	x 50.00	150.00
Independent Claims	4	- 4 =	0	x 0.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					<b>150.00</b>
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input type="checkbox"/> No additional fee is required for this amendment.					
<input checked="" type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ 150.00 . A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 18-0013 as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
<div> Ronald P. Kananen Attorney Reg. No.: 24,104</div>				Dated: October 21, 2005	
RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750					



Docket No.: SON-1908/DIV  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Takeshi Nogami et al.

Application No.: 10/759,194

**Confirmation No.: 7751**

Filed: January 20, 2004

Art Unit: 2823

For: METHOD FOR PRODUCING  
SEMICONDUCTOR DEVICE, POLISHING  
APPARATUS, AND POLISHING METHOD

Examiner: F. L. Toledo

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated August 8, 2005 (Paper No./Mail Date 20050807), please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.

10/24/2005 HALI11 00000073 180013 10759194

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